



P/1250-253

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

New York, New York

Tatsufumi KUSUDA

Date: September 5, 2003

Serial No.: 10/620,874

Group Art Unit:

Filed: July 16, 2003

Examiner:

For: THERMAL PROCESSING APPARATUS PERFORMING IRRADIATING A
SUBSTRATE WITH LIGHT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUBMISSION

Sir:

Submitted herewith is a copy of art together with a form listing the same
for the convenience of the Examiner.

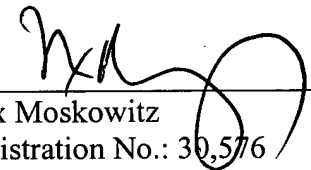
I hereby certify that this correspondence is being
deposited with the United States Postal Service as
first class mail in an envelope addressed to:
Commissioner for Patents P.O. Box 1450,
Alexandria, VA 22313-1450, on September 5,
2003

Respectfully submitted,

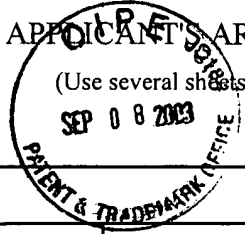
Max Moskowitz
Name of applicant, assignee or
Registered Representative


Signature

September 5, 2003
Date of Signature


Max Moskowitz
Registration No.: 30,576
OSTROLENK, FABER, GERB & SOFFEN, LLP
1180 Avenue of the Americas
New York, New York 10036-8403
Telephone: (212) 382-0700

MM:cg
Enclosures

 <p>APPLICANT'S ART CITATION (Use several sheets if necessary)</p>		Application 10/620,874		OFGS File No. P/1250-253		
		Applicant Tatsufumi KUSUDA, et al.				
		Filing Date 7/16/03		Group Art Unit		
U.S. PATENT DOCUMENTS						
▼ Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub-class	Filing Date If Appropriate
	US-4,525,380	06-1985	Arai, et al.			
	US-4,649,261	03-1987	Sheets			
	US-					
	US-					
	US-					
FOREIGN PATENT DOCUMENTS						
	Document Number	Date MM-YYYY	Country	Class	Sub-class	Translation Yes No
	11-135449 /	1999	Japan			X
	63-166219 /	1988	Japan			X
	59-169125 /	1984	Japan			X
	60-258928 /	1985	Japan			X
	57-162340 /	1982	Japan			X
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)						
	English translation of portion of Japanese Patent Application Laid-Open No. 11-135449					
	relevant to the instant application					
	English translation of portion of Japanese Patent Application Laid-Open No. 63-166219					
	relevant to the instant application					
	English translation of portion of Japanese Patent Application Laid-Open No. 57-162340					
	relevant to the instant application					
Examiner		Date Considered				
<small>EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.</small>						